



PATENT  
81839.0142

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Eiichi IINO, et al.

Serial No: 10/695,609

Filed: October 28, 2003

For: SILICON SEED CRYSTAL AND  
METHOD FOR PRODUCING  
SILICON SINGLE CRYSTAL

Art Unit: 1722

Examiner: M. A. Anderson

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Mail Stop Appeal Brief-Patents  
Commissioner for Patents  
P.O. Box 1450  
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October 5, 2006

Date of Deposit

John P. Scherlacher, Reg. No. 23,009

Name

John P. Scherlacher 10/05/06

Signature

Date

**PETITION FOR EXTENSION OF TIME**

Mail Stop Appeal Brief-Patents  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Board of Appeals for a further one-month extension of time extending to October 19, 2006, the period for response to the final Office Action dated April 19, 2006. A petition for a 2-month extension of time was filed on August 25, 2006. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: October 5, 2006

By:

John P. Scherlacher

Registration No. 23,009

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